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B2 Data Sheet

CONFIRMATION NO. 1952

SERIAL NUMBER 09/884,648	FILING DATE 09/28/2001 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 882.C2397	
APPLICANTS Kaji Yoshimura, Techigi, JAPAN; * CONTINUING DATA PONG R * FOREIGN APPLICATIONS JAPAN 2000/302162 10/02/2000 JAPAN 2001/089762 03/27/2001 IF REQUIRED, FOREIGN FILING LICENSE GRANTED * 11/14/2001					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 118 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Not enter not Allowed Verified and Acknowledged <input checked="" type="checkbox"/> Signature _____ Initials _____		STATE OR COUNTRY JAPAN	SHEETS DRAWING 15	TOTAL CLAIMS 27 11	INDEPENDENT CLAIMS 18 4
ADDRESS 05514					
TITLE Exposure apparatus, semiconductor device manufacturing method, exposure apparatus maintenance method and semiconductor manufacturing factory					
FILING FEE RECEIVED 1398	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		

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